

Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	10/672,029
				Filing Date	September 25, 2003
				First Named Inventor	Thomas S. Dory
				Art Unit	1753
				Examiner Name	Not Assigned
Sheet	2	of	2	Attorney Docket Number	42P16663

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
LV	8	HONG-HUI HSU ET AL., "Displacement Activation of Tantalum Diffusion Barrier Layer for Electroless Copper Deposition", Journal of the Electrochemical Society, 2001, pp. C590-C598, XP-002313839, XP-002313840, The Electrochemical Society, Inc., USA		
LV	9	International Search Report, International App. No.: PCT/US2004/031447, Applicant Ref. No.: P16663PCT, Completion Date: 18 Jan. 2005, Date Mailed: 27 Jan. 2005, pages: 5.		

Examiner Signature	<i>Har Van</i>	Date Considered	11/28/05
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

¹Applicant's unique citation designation number.²Applicant is to place a check mark here if English language Translation is attached.

Based on PTO/SB/08B (08-03) as modified by Blakely, Solokoff, Taylor & Zafman (wlr) 08/11/2003.
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